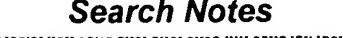


<b>Search Notes</b> 	<b>Application/Control No.</b> 10/655,309	<b>Applicant(s)/Patent under Reexamination</b> LEE, BYEONG-CHEOL
	<b>Examiner</b> D. Rutledge	<b>Art Unit</b> 2851

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
355	53, 55	5/19/2005	DR
355	67-71	5/19/2005	DR
356	399-401	5/19/2005	DR
250	205, 548	5/19/2005	DR